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PATENT APPLICATION
Attorney Docket: 10971608-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ruby et al

Serial No.: 09/088,964

Filed: 6/2/98

For: SBAR Structures and Method of Fabrication
of SBAR.FBAR Film Processing
Techniques for the Manufacturing of
SBAR/FBAR Filters

Group Art Unit: 2834

Examiner: T. Dougherty

Response to Restriction Requirement

Hon. Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

Election

In response to the restriction requirement, Applicant elects Claims 1-6.

I hereby certify that this paper (along with any others attached hereto) is being deposited with the United States Postal Service as first class mail with sufficient postage on the date signed below in an envelope addressed to: Hon. Assistant Commissioner of Patents, Box Amendment, Washington, D.C. 20231.

Respectfully Submitted,

Calvin B. Ward
Registration No. 30,896
Date signed and mailed: October 6, 1999

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